



UNITED STATES DEPARTMENT OF COMMERCE
Patent and Trademark Office
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APPLICATION NUMBER	FILING DATE	FIRST NAMED APPLICANT	ATTORNEY DOCKET NO.
09/526,100	3/15/2000	Sheppard	6019.3026

EXAMINER	
Jason J. Chung	
ART UNIT	PAPER NUMBER

2611 20

DATE MAILED:

INTERVIEW SUMMARY

All participants (applicant, applicant's representative, PTO personnel):

- (1) Jason Chung (3) Craig Hallacher
(2) Vivek Srivastava (4) Charles Eldering

Date of Interview 4/20/2004

Type: ☐ Telephonic ☐ Televideo Conference ☒ Personal (copy is given to ☐ applicant ☒ applicant's representative).

Exhibit shown or demonstration conducted: ☒ Yes ☐ No If yes, brief description: overhead projection

Agreement ☐ was reached. ☒ was not reached.

Claim(s) discussed: Independent claims

Identification of prior art discussed: Ehreth, Hamlin, Martin, & Martinez

Description of the general nature of what was agreed to if an agreement was reached, or any other comments: Discussed Independent claims with regard to residential gateway directly receiving signals. Discussed Martinez with regard to IR sending pulse trains to bias switch.

(A fuller description, if necessary, and a copy of the amendments, if available, which the examiner agreed would render the claims allowable must be attached. Also, where no copy of the amendments which would render the claims allowable is available, a summary thereof must be attached.)

☐ It is not necessary for applicant to provide a separate record of the substance of the interview.

Unless the paragraph above has been checked to indicate to the contrary. A FORMAL WRITTEN REPLY TO THE LAST OFFICE ACTION IS NOT WAIVED AND MUST INCLUDE THE SUBSTANCE OF THE INTERVIEW. (See MPEP Section 713.04). If a reply to the last Office action has already been filed, APPLICANT IS GIVEN ONE MONTH FROM THIS INTERVIEW DATE TO FILE A STATEMENT OF THE SUBSTANCE OF THE INTERVIEW.

Examiner Note: You must sign this form unless it is an attachment to another form.

VIVEK SRIVASTAVA
PRIMARY EXAMINER